

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application for:

**Kevin J. Lee**

Serial No. 10/808,763

Filed: March 24, 2004

For: CONTROLLED POTENTIAL ANODIC  
ETCHING PROCESS FOR THE  
SELECTIVE REMOVAL OF  
CONDUCTIVE THIN FILMS

Examiner: Lois L. Zheng

Art Unit: 1742

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Ma'am:

In response to the Office Action dated January 16, 2007, please amend the above-captioned application as set forth below.

**Amendments to the Drawings** are reflected on page 2 of this response.

**Amendments to the Claims** are reflected in the listing of claims and begins on page 3 of this response.

**Remarks/Arguments** begin on page 4 of this response.